



Air/Manually Operated High Purity Chemical Valve Series LV



PAT. PEND.

Responding to the latest demands in process control.





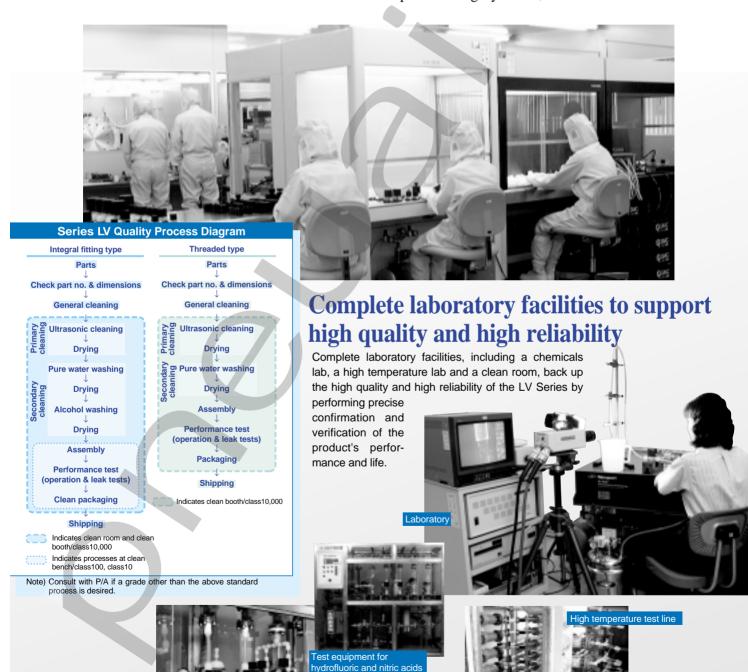


Responding to the latest demands in process control P/A High Purity Series

High levels of purity are increasingly required in the handling of fluids for advanced processing applications of semiconductors, pharmaceuticals, medicine, instrumentation, cleaning and food processing.

P/A high purity series products incorporate many new and unique innovations that minimize both particulate and chemical contamination to levels compatible with the most demanding requirements.

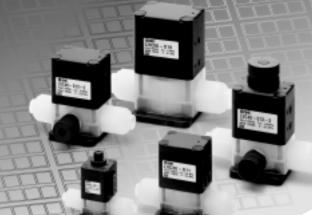
Cleaning, assembly and packaging are performed in a clean room to ensure the ultimate in product integrity.



o aire







Air/Manually Operated High Purity Chemical Valve

Series LV

Integral Fitting Valves/Series LVC

Low particle generation

Piston bumper

A bumper absorbs piston momentum to minimize impact-induced particles.

Stable Sealing Surface Guide ring

A unique guide ring on the piston rod eliminates lateral motion of the poppet, greatly increasing seal life and reducing particle formation.

Prevents Micro-Bubbles

Diaphragm (PTFE)

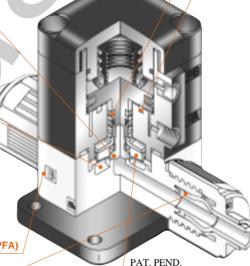
Special diaphragm construction insures gentle opening and closing that prevents the formation of micro-bubbles.

Minimal dead space

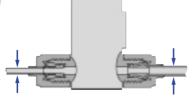
In addition to a body designed for smooth flow with minimal internal dead space, integral fittings eliminate the possibility of residual liquid in pipe threads.



Compatible with chemicals such as acids, bases and ultrapure water.



Different tubing sizes can be selected Hyper fitting



- No leak design (quadruple seal)
- Eliminates problems due to over tightening (special locking mechanism)
- High flexural strength (tube supports)

POWER O AIRE

Back-pressure resistance and long life Buffer

The diaphragm is supported by a buffer that minimizes deformation, which gives it long life and resistance to back-pressure.

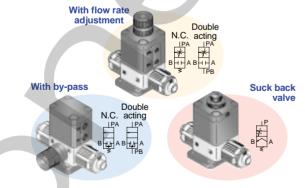








Numerous variations



- N.C./N.O. with same configuration/Double acting
- **Compatible with 100°C fluid temperature**

Integral Fittings-Series LVC Main applications and fields IC manufacturing lines Analytical linstruments Pharmaceutical manufacturing equipment Cleaning equipment



Air Operated

Integral Fitting Type Series LVC

	7	Model	LVC20/23	LVC30	LVC40	LVC50
Tu	Orifi	ice diameter	σ4.	ø8	ø10	ø16
	Orifi be outside dia	Millimeter	4, 6	6, 8, 10	10, 12	12, 19
Туре		Valve type	1/8, 1/4, 3/16	1/4, 3/8	3/8, 1/2	1/2, 3/4
Basic type	_PA _PB	N.C.	0	0	0	0
	BHHA BHA	BHA N.O.	0	0	0	0
		Double acting	0	0	0	0
With flow rate adjustment	BHHA BH	^{LPA} ★ N.C.	0	0	0	0
	N.C. Dou	Double acting	0	0	0	0
With by-pass		N.C.	_	0	0	0
	N O Doi	ting Double	_	0	0	0
With flow rate adjustment and by-pass	*	⊮A N.C.	_	0	0	0
	N.C. Do	uble ting Double acting	_	0	0	0
Suck back	,P ★ A B	Single type	0	_		_
	Cinalo	J _{nit} Unit	0	_	_	

Air Operated
Threaded Type Series LVA PROPERTY P.7 to P.14

moddod Typ	e deries E 7									, ,,	<i>-</i>	• • •
		Model	LV	A10	LVA	120	LV	430	LV	A40	LV	450
	Orifice dia	ameter	Ø	2	ø	4	ø	8	ø.	12	ø2	20
	Body m	size	1/8	1/4	1/8	1/4	1/4	3/8	3/8	1/2	1/2	3/4
\ \	Body material SL	IS316 PS	0	0	0	0	0	0	0	0	0	0
)/A/	0	0	_	0	_	0	_	0	_	0
Туре	Symbol P	A.	_	_	_	0	_	0	_	0	_	0
Basic type	PA PB PA	N.C.	0	0	0	0	0	0	0	0	0	0
	BUIA BUIA BUIA	N.O.	_	_	0	0	0	0	0	0	0	0
	N.C. N.O. Double acting	Double acting	_	_	0	0	0	0	0	0	0	0
With flow rate adjustment	PA PHA BHHA	N.C.	_	_	0	0	0	0	0	0	0	0
		Double acting	_	_	0	0	0	0	0	0	0	0
Manifold (5 stations max.)												

Manually Operated Series LVH >>>>>>>>>> P.15 to P.20 Integral Fitting Type

	Model	LVH20	LVH30	LVH40
	Orifice diameter ube outside dia. Millimeter	ø4	ø8	ø10
		4, 6	6, 8, 10	10, 12
Туре	Symbol Valve type	1/8, 3/16, 1/4	1/4, 3/8	3/8, 1/2
Basic type	BUJA BUJA N.C. Non-locking Locking	0	0	0

Threaded Type

	Model Orifice diameter		ø4			LVH30			LVH40					
						ø8				ø12				
		Material	SUS	316	PPS	PFA	SUS	316	PPS	PFA	SUS	316	PPS	PFA
Type S	Symbol	Port size	1/8	1/4	1/4	1/4	1/4	3/8	3/8	3/8	3/8	1/2	1/2	1/2
Basic type	É	N.C.	0	0	0	0	0	0	0	0	0	0	0	0
Manifold (5 stations max.)														









Applicable Fluids

Material and fluid compatibility check list for air and manually operated high purity valves

		Body mate	rial	Diaphragm material				
Chemical	Stainless steel SUS316 Fluoro re		Polyphenylene sulfide resin PPS	Fluoro resin PTFE	Nitrile rubber NBR	Ethylene propylene rubber EPR		
Acetone	0	△ Note 1)	△ Note 1)	△ Note 2)	Х	0		
Ammonium hydroxide	0	0	0	△ Note 2)	X	0		
Isobutyl alcohol	0	△ Note 1)	△ Note 1)	△ Note 2)	0	0		
Isopropyl alcohol	0	△ Note 1)	△ Note 1)	△ Note 2)	0	0		
Hydrochloric acid	Х	0	0	0	X	Χ		
Ozone (dry)	0	0	0	0	Х	0		
Hydrogen peroxide Concentration 5% or less, 50°C or less	Х	0	0	0	X	Х		
Ethyl acetate	0	△ Note 1)	△ Note 1)	△ Note 2)	X	Χ		
Butyl acetate	0	△ Note 1)	△ Note 1)	△ Note 2)	Х	Х		
Nitric acid (except fuming nitric acid) Concentration 10% or less	х	0	0	△ Note 2)	Х	Х		
Pure water	0	0	0	0	Х	0		
Sodium hydroxide Concentration 50% or less	0	0	0	0	Х	Х		
Nitrogen gas	0	0	0	0	0	0		
Ultrapure water	Х	0	0	0	X	Х		
Toluene	0	△ Note 1)	△ Note 1)	△ Note 2)	Х	Х		
Hydrofluoric acid	Х	0	Х	△ Note 2)	Х	Х		
Sulfuric acid (except fuming sulfuric acid)	Х	0	Х	△ Note 2)	Х	0		
Phosphoric acid Concentration 80% or less	Х	0	Х	0	Х	Х		

The material and fluid compatibility check list provides reference values as a guide only.

Note 1) Use a stainless steel body, as static electricity may be generated. Note 2) Use caution as permeation may occur.

• Compatibility is indicated for fluid temperatures of 100°C or less.

• Consult P/A regarding fluids other than the above.

· Consult P/A regarding operating conditions.

Table symbols ○: Can be used

 \triangle : Depends on conditions

X: Cannot be used



